

## UNITED STATES PATENT AND TRADEMARK OFFICE

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GROUP ART UNIT

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## **CONFIRMATION NO. 5477**

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	RULE					
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** CONTINUING DATA **********************************						
** FOREIGN APPLICATIONS ************************************						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed 35 USC 119(a-d) conditions met		STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS	
Verified and /TRAN Q T Acknowledged Examiners		JAPAN	4	17	6	
ADDRESS						
SCULLY SCOTT MURPHY & PRESSER, PC						

CLASS

438

## TITLE

SUITE 300 GARDEN CITY, NY 11530 UNITED STATES

Porous substrate and its manufacturing method, and gan semiconductor multilayer substrate and its manufacturing method

☐ All Fees	
□ 1.16 Fees (Fi	ng)
FILING FEE FEES: Authority has been given in Paper No	ocessing Ext. of time)
1630 No for following:	ue)
☐ Other	
☐ Credit	